RSC Advances

PAPER

Cite this: RSC Adv., 2017, 7, 45484

Received 1st August 2017 Accepted 19th September 2017

DOI: 10.1039/c7ra08480c

rsc.li/rsc-advances

1 Introduction

Multi-functional thin films that simultaneously function as thin film heaters (TFHs) and heat shielding film (HSFs) have attracted great interest because of the demand for functional glass for automobiles and smart windows for building energy management systems (BEMSs).¹⁻⁵ To achieve simultaneous heat generation and heat shielding performance, fabrication of metal-based electrodes on flexible substrates with low sheet resistance, high transmittance, and good mechanical flexibility is critical. Although thick metal films easily generate high temperatures through resistance heating by applying power and shielding heat by absorbing near infrared (NIR) wavelengths, these films cannot be employed as smart window films due to their inherent opacity.⁶ Therefore, to realize multi-functional TFHs and HSFs for application to transparent glass windows or curved glass windows, the development of thin metal-based semi-transparent electrodes with low sheet resistance, smooth morphology, good mechanical flexibility, and environmentally stability is imperative. Because metal thin films with a thickness

Highly flexible and semi-transparent Ag–Cu alloy electrodes for high performance flexible thin film heaters†

Kyung-Su Cho,^a Eunah Kim,^b Dong-Wook Kim^b and Han-Ki Kim ^{D *a}

We investigated the properties of thermally evaporated Ag–Cu films for application as flexible and semitransparent electrodes for semi-transparent flexible thin film heaters (TFHs) and heat shielding films (HSFs). The effects of Ag–Cu thickness on the electrical, optical, morphological, and mechanical properties of the Ag–Cu films were investigated in detail. Based on figure of merit values calculated from the sheet resistance and optical transmittance, we optimized the thickness of the Ag–Cu alloy film. Optimized film showed no resistance changes and no cracks, even with inner and outer bending radii smaller than 5 mm, indicating sufficiently high flexibility for application in TFHs and HSFs. In addition, we measured the work function of the Ag–Cu films using Kelvin probe force microscopy to correlate the work function and surface morphology. The effect of the thickness of the Ag–Cu alloy electrodes on the saturation voltage and temperature of flexible TFHs was also investigated. In addition, we investigated the feasibility of using semi-transparent Ag–Cu alloy film in HSFs. Effective heat generation and heat shield performance of Ag–Cu alloy films suggest that the multi-functional Ag–Cu films described here can potentially be applied to create energy-efficient automobile windows and smart windows for building energy management systems. PAPER

(a) Checkforgodates

(a) Checkforgodates
 $\frac{1}{2}$ Checkforgodates

Checkforgodates

Checkforgodates

Checkfords for high performance flexible thin film

Checkfor Airport (Agriculture Checkfors)
 $\frac{1}{2}$ Checket

below skin depth display fairly high optical transparency, optimization of metal film thickness is very important to fabricate high quality semi-transparent metal thin film electrodes for high performance TFHs and HSFs.⁷ In particular, thermal response time, steady heating temperature, operating voltage, temperature uniformity, and cycling stability of TFHs are critically affected by the quality of semi-transparent electrodes.⁸⁻¹⁰ Sn-doped In₂O₃ (ITO) films are currently widely used as transparent electrodes for transparent TFHs because of their high optical transmittance and conductivity.^{8,11,12} However, the brittleness of thick ITO films and the high cost of indium limit the application of ITO films as cost-effective flexible transparent electrodes for flexible TFHs.¹³ Conventional ITO electrodes need to be replaced by highly flexible electrodes to realize high performance flexible TFHs and HSFs. Although several transparent electrodes made of materials such as conducting polymers, carbon (carbon nanotubes, graphene), metal nanowires, metal meshes, conductive oxides, and oxide-metal-oxides have been developed to replace ITO film in transparent TFHs, there are no reports of semi-transparent and flexible metal electrodes prepared by thermal evaporation for flexible TFHs and HSFs.^{1,8,14-29} In particular, flexible semi-transparent metal electrodes that can simultaneously act as heating electrodes in flexible TFHs and heat shielding electrodes in HSFs have not been investigated.

In this study, we report the electrical, optical, morphological, and mechanical properties of thermally evaporated Ag–Cu alloy

a Kyung Hee University, Department of Advanced Materials Engineering for Information and Electronics, 1 Seocheon, Yongin, Gyeonggi-do 446-701, Republic of Korea. E-mail: imdlhkkim@khu.ac.kr; Fax: +82-31-205-2462; Tel: +82-31-201-2462

b Department of Physics, Ewha Womans University, Seoul 120-750, Republic of Korea † Electronic supplementary information (ESI) available. See DOI: 10.1039/c7ra08480c

films on PET substrate as a function of thickness for use as flexible and semi-transparent electrodes for flexible TFHs and HSFs. To optimize the thickness of the Ag-Cu alloy, the figure of merit (FOM) values of Ag-Cu alloy films were calculated based on sheet resistance and optical transmittance. The mechanical flexibility of the optimized Ag–Cu alloy film was investigated using a lab-designed inner bending, outer bending, and twisting test system. Furthermore, the performances of flexible TFHs and HSFs with Ag–Cu alloy electrodes were examined to explore the feasibility of using Ag-Cu alloy films as semitransparent electrodes for high-performance flexible TFHs and HSFs.

2 Experimental

2.1 Thermal evaporation of Ag-Cu alloy films

Ag–Cu alloy films were thermally evaporated films as a function of film thickness (8 to 16 nm) on 150 µm-thick PET substrate using a lab-scale thermal evaporation system (15NNS005, NNS Vacuum). At a base pressure of 1×10^{-6} Torr, the Ag–Cu alloy films were thermally evaporated onto the PET substrate as a function of thickness; the operating conditions were applied voltage of 0.37 V, applied current of 54 A, Z-factor of 0.529, tool factor of 154%, and loading plate rotation speed of 10 rpm. The Ag–Cu alloy (90 wt% Ag–10 wt% Cu) source was loaded onto a conventional tungsten boat. The exact thickness of the Ag–Cu alloy films was controlled by a quartz thickness monitor (STM-100MF, Sycon) placed near the substrate holder.

2.2 Characterization of thermally evaporated Ag–Cu alloy films

Electrical and optical properties of the thermal evaporated Ag– Cu layer were examined using Hall measurements (HL5500PC, Accent Optical Technology) and a UV/visible spectrometer (UV 540, Unicam) as a function of film thickness. The mechanical properties of the Ag–Cu layers were evaluated using a specially designed inner and outer bending system. The outer bending test induced tensile stress on the film, whereas the inner bending test induced compressive stress. In addition, dynamic fatigue bending and twisting tests were performed using a labdesigned cyclic bending and twisting test machine, operated at a frequency of 0.5 Hz for 10 000 cycles. The resistance of the Ag– Cu layers was measured throughout cyclic bending. Field emission scanning electron microscopy (FESEM) was employed to investigate the surface morphology of the Ag-Cu alloy films before and after bending tests. The work function and topography of the Ag–Cu alloy films were examined using Kelvin probe force microscopy (KPFM). KPFM measurements were conducted using an atomic force microscopy (AFM) system (XE-100, Park Systems) under ambient conditions (temperature: 25.5 \degree C, humidity: 26%). Conductive Pt-coated Si cantilevers (NSG 10/Pt, NT-MDT) were used for both work function and topography measurements. The work function of the tip was calibrated with highly ordered pyrolytic graphite (HOPG, SPI Supplies).

2.3 Fabrication and evaluations of TFHs and HSFs

To demonstrate the feasibility of the Ag–Cu alloy films as a semi-transparent electrode for TFHs and HSFs, TFHs with a size of 25 \times 25 mm² were fabricated (ESI Fig. S1†). To apply power to the semi-transparent TFHs, two-terminal side Ag contacts were sputtered on the edge of the semi-transparent Ag– Cu layer film. DC voltage was supplied by a power supply (OPS 3010, ODA technologies) to the Ag–Cu based TFHs through an Ag contact electrode at the film edge. The temperature of TFHs was measured using a thermocouple mounted on the surfaces of the TFHs and an IR thermal imager (A35sc, FLIR). To investigate the performance of Ag–Cu alloy-based HSFs, we irradiated conventional glass substrate with a halogen lamp and measured the surface temperature of the glass substrate using an IR thermometer (62-MAX, Fluke) with or without screening the halogen lamp using semi-transparent Ag-Cu films. Paper Work (Fig. 22 CAD (Fig. 22 CAD (Fig. 22 CAD (Fig. 22 CAD (Fig. 23 CAD (Fig. 23 CAD (Fig. 24 CAD (F

3 Results and discussion

Fig. 1a shows a schematic of the thermal evaporation process used to fabricate semi-transparent Ag-Cu alloy films on flexible PET substrate. The Ag-Cu films were evaporated as a function of Ag-Cu thickness onto bare flexible PET substrate attached to a cooling substrate holder at a temperature of 16.8 $^{\circ}$ C; the operating conditions were 0.37 V and 54 A. During thermal evaporation of the Ag–Cu alloy films, the PET substrate was constantly rotated at a speed of 10 rpm to ensure a uniform Ag– Cu layer thickness. Fig. 1b shows semi-transparent Ag–Cu alloy film with a thickness of 14 nm and semi-transparent flexible TFHs. Because the thickness of Ag-Cu film is similar to the skin depth of Ag (13 nm), the Ag-Cu film had a bluish color and was

Fig. 1 (a) Schematic of the thermal evaporation process used to fabricate flexible and semi-transparent Ag–Cu alloy films on a flexible PET substrate. (b) Photograph of the semi-transparent Ag–Cu alloy film with a bluish color and a curved TFH with Ag edge contact electrodes.

Fig. 2 (a) Sheet resistance, resistivity, (b) mobility, and carrier concentration of thermal evaporated Ag–Cu alloy films on PET substrates with increasing thickness from 8 to 16 nm. (c) Optical transmittance of Ag–Cu alloy films in the visible wavelength region as a function of increasing film thickness. (d) Figure of merit (FOM) values of Ag–Cu alloy films calculated from sheet resistance (R_s) and optical transmittance (T) values at a wavelength of 550 nm.

semi-transparent.³⁰ The Kyung Hee University insignia behind the Ag–Cu/PET sample was clearly visible due to the high transparency of the Ag-Cu film.

Fig. 2a and b show Hall measurement results of the Ag–Cu alloy films as a function of film thickness (8 to 16 nm). The Ag-Cu alloy film less than 8 nm thick did not show electrical conductivity due to disconnected Ag–Cu islands in the initial growth region. As we reported previously, a sputtered Ag layer on oxide film tends to agglomerate and form disconnected islands in the initial growth region due to the high surface energy of Ag atoms.³¹ However, further increases in Ag–Cu alloy film thickness led to connection of islands and a layered film, which acted as a conducting path. Therefore, Ag-Cu alloyed film thicker than 8 nm started to show resistivity and sheet resistance. The resistivity of Ag-Cu films decreased significantly from 3.10×10^{-5} Ohm cm to 6.39×10^{-6} Ohm cm due to the improved connectivity of the Ag–Cu alloy layer. Fig. 2b shows the mobility and carrier concentration of the Ag–Cu alloy films as a function of film thickness. An increase in film thickness led to an increase in carrier mobility due to the improved

connectivity of the Ag–Cu layer. However, Ag–Cu films showed a similar carrier concentration regardless of film thickness. Therefore, we attributed the decreased resistivity of the Ag–Cu layer to an increase in carrier mobility. As discussed by Roh $et al., Cu in the Ag-Cu-Pd alloy diffuses to the surface of Ag film$ and decreases surface diffusion of the Ag film.²⁹ This decreased surface diffusion improves the thermal stability of Ag film. Because of the thermal stability conferred by Cu, we employed Ag–Cu alloy film as a semi-transparent electrode for flexible TFHs. Fig. 2c shows the optical transmittance of the Ag–Cu alloy film in the visible wavelength region as a function of Ag-Cu alloy film thickness. Because of the thinness of the Ag–Cu alloy film, all films demonstrated semi-transparency above 50% at a wavelength of 550 nm. The 14 nm-thick Ag-Cu alloy film had an optical transmittance of 53.62% at 550 nm. Increasing the thickness of the Ag–Cu layer from 8 to 16 nm resulted in a significant decrease in the optical transmittance of Ag–Cu alloy films in the NIR region due to reflection of this wavelength by the Ag–Cu alloy layer. Based on the sheet resistance (R_s) and transmittance (T) values of the Ag–Cu alloy films at a wavelength

Table 1 Comparison of figure of merit values of the evaporated Ag–Cu alloy film, semi-transparent metal films and sputtered ITO films

Fig. 3 (a) Change of sheet resistance of Ag–Cu alloy film in PET substrate over time. (b) XRD plot of evaporated Ag–Cu alloy film.

of 550 nm, we calculated figure of merit (FOM = T^{10}/R_s) values as a function of thickness to optimize film thickness for a semitransparent electrode, as shown in Fig. 2d.³³ Due to low sheet resistance and high optical transmittance, the 14 nm-thick Ag– Cu alloy film showed the highest FOM value $(3.5 \times 10^{-4} \Omega^{-1})$. Therefore, we chose the optimum thickness of the thermal evaporated Ag–Cu alloy film as 14 nm, which is similar to skin depth of light.³⁰ Table 1 compared the FOM values of the evaporated Ag–Cu alloy films, several semi-transparent metals and ITO electrodes. For comparison, we prepared the several thermal evaporated semi-transparent electrode (Ag, AgPdCu, Al–Cu) with same thickness and sputtered ITO electrode except Cu–Ni film.³⁴ Compared to the other semi-transparent metal electrodes, the Ag-Cu alloy film showed higher FOM values due to its higher optical transmittance. To investigate the stability of Ag–Cu alloy film, we measured the sheet resistance change as a function of time as shown in Fig. 3a. The evaporated Ag–Cu alloy films showed a constant sheet resistance with increasing time indicating outstanding stability against ambient. In

general, Cu films or Cu nanoparticles easily react with oxygen atoms in ambient and easily form Cu–O phases on the surface.³⁵ However, the Ag–Cu alloy films showed a constant sheet resistance regardless of time because the contents of the Cu element in the evaporated Ag–Cu alloy is fairly low. The preferred Ag (111) peak ($2\theta = 38.22^{\circ}$) in X-ray diffraction plot of the Ag–Cu (14 nm)/PET sample (Fig. 3b) indicates the low content of Cu element in the evaporated Ag–Cu alloy films.

Fig. 4 shows surface FESEM images of 6, 8, and 16 nm-thick Ag-Cu alloy and bare Ag films evaporated on PET substrates. As expected from the sheet resistance of Ag–Cu alloy films in Fig. 2a, the connectivity of Ag–Cu alloy films was critically dependent on film thickness. Surface FESEM images obtained for the 6 nm-thick Ag–Cu alloy layer showed an island-shaped Ag–Cu layer caused by severe agglomeration of the Ag–Cu alloy atoms. As illustrated to the right in Fig. 4a, the unconnected Ag–Cu alloy prevented effective conduction of carriers and reduced carrier mobility. Because the 6 nm-thick Ag–Cu alloy consisted of unconnected islands, it did not show sheet

Fig. 4 Surface FESEM images and schematic cross-sectional structure of Ag–Cu alloy film on PET substrates obtained from (a) 6 nm-, (b) 8 nm-, and (c) 16 nm-thick Ag–Cu alloy films. Surface FESEM images of (d) 6 nm-, (e) 8 nm-, and (f) 16 nm-thick bare Ag films on PET substrate

Fig. 5 (a) Outer and inner bending tests of the 14 nm-thick Ag–Cu alloy film with decreasing bending radius. (b) Dynamic fatigue tests of the 14 nm-thick Ag–Cu alloy film with increasing bending cycles. (c) Twisting test of the Ag–Cu alloy film with repeated twisting cycles. Inset pictures demonstrate outer/inner bending of samples, dynamic bending steps, and twisting steps.

resistance or resistivity because of the absence of an effective conduction path, as expected (Fig. 2a). However, the 8 nm-thick Ag-Cu alloy film showed improved connectivity due to connection of the Ag–Cu islands. Due to a decrease in surface diffusion, the Ag–Cu alloy film showed well-connected islands, even at a thickness of 8 nm.³² However, some regions, indicated by the arrows, remained unconnected, and this unconnected region increased the resistivity of the Ag–Cu alloy film (Fig. 4b). In case of the evaporated Ag films with a thickness of 6 and 8 nm (Fig. 4d and e), they showed unconnected Ag islands due to high surface diffusion of the evaporated Ag atoms on the PET surface. Due to formation of unconnected Ag islands, the evaporated Ag film didn't show metallic conductivity even at the 8 nm thickness unlike evaporated Ag-Cu alloy film. A further increase in Ag–Cu alloy and Ag film thickness led to a layered structure, which completely covered the PET substrate, as shown in Fig. 4c and f, and improved the connectivity of the Ag– Cu alloy film.

To evaluate the mechanical flexibility of optimized Ag–Cu alloy films (14 nm) as flexible electrodes for semi-transparent flexible TFHs and HSF, we measured resistance changes (ΔR) during outer and inner bending using an in-house bending test system. Fig. 5a shows the results of outer/inner bending tests of the Ag–Cu alloy films with decreasing bending radius. The outer bended Ag–Cu film experienced tensile stress, while the inner bended Ag–Cu film experienced compressive stress, as illustrated in the insets of Fig. 5a. The change in resistance of Ag–Cu alloy films can be expressed as $(\Delta R = R - R_0)/R_0$, where R_0 is the initial measured resistance, and R is the in situ measured resistance under substrate bending. The outer/inner bending test results showed that the 14 nm-thick Ag-Cu alloy films had a constant resistance change (ΔR) until the bending radius of 1 mm (limit of our bending test system) due to the high flexibility of the Ag–Cu alloy film. The following equation can be used to calculate the peak strain for a curved Ag-Cu alloy film with decreasing bending radius:³⁶

$$
\text{Strain} = \frac{d_{\text{Ag}-\text{Cu}} + d_{\text{PET}}}{2R} \times 100 \tag{1a}
$$

Here, d_{Ag-Cu} and d_{PET} are the thickness of the Ag–Cu alloy film and the PET substrate, respectively. Bending of the 14 nmthick Ag–Cu alloy on a 150 μ m-thick PET substrate to a bending radius of 1 mm resulted in a peak strain of 7.5%. This flexibility is sufficient for fabrication of highly flexible TFHs and HSFs. Fig. 5b shows the dynamic outer and inner bending fatigue test results obtained for the 14 nm-thick Ag–Cu alloy film with increasing repeated bending cycles at a fixed bending radius of 5 mm, which is acceptable for fabrication of flexible TFHs attached to a rounded glass substrate. The insets in Fig. 5b are pictures of dynamic outer/inner bending test steps with increasing bending cycles. Both dynamic outer and inner bending fatigue tests of the thermally evaporated Ag–Cu alloy film revealed no change in resistance after 10 000 bending cycles, indicating that the Ag-Cu alloy film had good flexibility and stability. Fig. 5c shows the results of a dynamic twisting test of the 14 nm-thick Ag–Cu layer with increasing twisting cycles at a fixed twisting angle of 15°. The $\Delta R/R_0$ value of the Ag–Cu layer electrode was almost unchanged with increasing repeated twisting cycles. Even after 1 mm outer/inner bending of the samples, the surface of the Ag–Cu alloy was similar to that of the as-deposited Ag–Cu alloy film, confirming the good flexibility of the Ag–Cu alloy film (ESI Fig. $S2\dagger$). In addition, the Ag–Cu alloy film showed a similar surface to the as-deposited sample even after 10 000 dynamic outer/inner bending cycles.

Fig. 6 (a) Topography images and (b) work function maps of Ag–Cu layers of various thicknesses ranging from 4 to 16 nm.

Table 2 Sheet resistance, optical transmittance, and work function of thermally evaporated Ag–Cu alloy films on PET substrate and the calculated figure of merit

	Sheet resistance Thickness $[Ohm sq.]-1[%]$	Transmittance _{550 nm}	Figure of merit $[10^{-3} \Omega^{-1}]$ [eV]	Work function
4 nm		42.44		$4.78 + 0.02$
6 nm		31.98		4.75 ± 0.01
8 nm	100.5	50.65	0.01	$4.75 + 0.02$
10 nm	21.5	49.86	0.04	4.98 ± 0.01
12 nm	8.02	54.82	0.31	$4.92 + 0.01$
14 nm	5.54	53.62	0.35	$4.96 + 0.01$
16 nm	3.99	49.04	0.20	5.06 ± 0.01

Fig. 6a and b show topography images and work function maps of Ag–Cu alloy films of various thicknesses. Using a Kelvin probe force microscopy (KPFM) system, we obtained surface topography and work function data for the same region. $37-40$ When the thickness of the Ag–Cu alloy film increased, the work function of the Ag-Cu film increased from 4.78 to 5.06 eV. As shown in Fig. 6a and b, neither surface morphology nor roughness influenced the measured work function value, ruling out any concerns about topographic artifacts in the KPFM measurements. The standard deviation of the work function data was very small (less than 0.5%), which suggests that the Ag–Cu alloy thin film had a homogeneous composition. Table 2

summarizes the sheet resistance, optical transmittance, figure of merit, and work function values obtained for thermally evaporated Ag–Cu layers of various thicknesses.

To investigate the feasibility of using thermally evaporated Ag–Cu alloy films as flexible and semi-transparent electrodes for flexible TFHs, flexible TFHs with a size of 25×25 mm² were fabricated using a two-terminal Ag contact configuration. Fig. 7a shows photographs of the fabrication of flexible TFHs with semi-transparent Ag–Cu alloy electrodes. DC voltage was applied to the flexible TFHs by a power supply through sputtered Ag contact electrodes at the film edge, as shown in Fig. 7a. The temperature profile of flexible TFHs was measured by a thermocouple placed on the surface of the TFHs. Fig. 7b shows the temperature profiles of the Ag-Cu alloy film-based TFHs, plotted with respect to input voltage as a function of Ag-Cu alloy film thickness from 8 to 16 nm. When DC voltage was supplied to the Ag–Cu alloy film-based TFHs, the temperature of the all-flexible TFHs gradually increased and reached the saturation temperature. As the input voltage was increased, the temperature of the flexible TFHs increased, as shown in all of the temperature profiles. It is noteworthy that the increase in Ag–Cu alloy thickness decreased the input DC voltage to achieve a temperature of 100 $^{\circ}$ C. In the case of flexible TFHs with an 8 nm-thick Ag-Cu alloy film, 8 V of input DC voltage was necessary to achieve 95 \degree C. An increase in Ag–Cu alloy film thickness to 16 nm led to a significant decrease in input DC voltage to 4 V to produce a temperature greater than 100 \degree C. The lower input voltage of the flexible TFHs with thicker Ag–Cu film to reach

Fig. 7 (a) Photographs of the fabrication process of flexible TFHs with semi-transparent Ag–Cu electrodes. (b) Temperature profile of flexible TFHs operated at different input voltages with increasing semi-transparent Ag–Cu alloy film thickness. The insets show IR images at the saturated temperature. (c) Saturation voltage and temperature of Ag–Cu alloy-based TFHs as a function of Ag–Cu thickness.

a temperature of 100 °C implies efficient transduction of electric energy into Joule heating in the Ag–Cu alloy-based flexible TFHs. The sheet resistance of Ag–Cu alloy electrodes and the saturated temperature of flexible TFHs are correlated. When power (P) is applied to flexible TFHs during heating for a certain amount of time (t), the generated heat (ΔQ_g) is the summation of heat loss due to conduction in the substrate (Q_{cond}) , heat loss due to convection in air (Q_{conv}) , and heat loss due to radiation (Q_{rad}) from flexible TFHs, as expressed in the following equation:8,24

$$
\Delta Q_{\rm g} = P \Delta t = \frac{V^2}{R} \Delta t = Q_{\rm cond} + Q_{\rm conv} + Q_{\rm rad}
$$
 (2a)

Here, V is the input DC voltage between the Ag contact electrodes, and T is the resistance of the TFHs. In our flexible TFH samples, heat loss due to conduction was negligible because the sample was not in contact with a good thermal conductor. In addition, heat loss caused by radiation was negligible below 100 °C because of the very low emissivity of the Ag–Cu alloy. Therefore, air convection is the main path of heat dissipation in Ag–Cu alloy-based flexible TFHs.⁴¹

$$
Q_{\text{conv}} = \frac{V^2}{R} \Delta t = h_{\text{conv}} A_{\text{conv}} (T_s - T_i)
$$
 (3a)

$$
T_{\rm s} = \frac{V^2 \Delta t}{Rh_{\rm conv} A_{\rm conv}} + T_{\rm i}
$$
 (3b)

In eqn (3a) and (3b), h_{conv} is the convective heat transfer coefficient, A_{conv} is the surface area, and T_s and T_i are the saturation and initial temperature, respectively. Based on these equations, it is apparent that the saturation temperature of flexible TFHs increases with increasing input DC voltage (V) and with decreasing resistance (R) . Therefore, flexible and semitransparent Ag–Cu alloy electrodes should have a low sheet resistance to realize high-performance flexible TFHs with a lower DC input voltage to achieve a temperature of 100 \degree C.

To investigate durability of the Ag–Cu alloy based TFHs, we performed repeated heating-cooling tests for 10 cycles. Fig. 8a shows the temperature profiles of the 16 nm thick-Ag-Cu alloy film-based TFHs for repeated 10 cycles. The Ag–Cu alloy films based TFHs showed an identical temperature profiles and easily reached at a saturation temperature of 100 °C when DC voltage of 4 V was applied. In addition, when the DC voltage of 4 V was supplied to Ag-Cu alloy film based TFHs for 1 hour, the TFHs keep a saturation temperature of 100 \degree C steady without temperature modulation as shown in Fig. 8b. The similar surface FESEM images of the Ag–Cu alloy film before and after heating in Fig. 8c and d also indicate the durability of the semitransparent Ag–Cu alloy films as an electrode for flexible and semi-transparent TFHs. Even after 10 000 times inner/outer bending cycles and 5000 times twisting cycles, the Ag–Cubased TFHs showed identical heating performances to asdeposited Ag–Cu based TFHs (ESI Fig. S3†) indicating outstanding stability and flexibility of the thermal evaporated Ag-Cu films. Paper

Moreover Access Article Complete Consider Article Consider Article is expected by the consider article is the complete Common Article is the common and th

The lower DC input voltage of flexible TFHs with a thicker Ag-Cu alloy electrode confirms that flexible and semitransparent electrodes with a lower sheet resistance are critical to obtain high-performance TFHs with a lower input DC voltage. To demonstrate the feasibility of Ag-Cu alloy film-based TFHs, a water droplet test was performed on the heated flexible

Fig. 8 (a) Temperature profiles of the Ag–Cu alloy based TFH under repeated hating and cooling for 10 cycles. (b) Temperature profile of the Ag– Cu alloy based TFHs when DC voltage of 4 V was supplied for 1 hour. Surface FESEM images of the Ag–Cu alloy film (c) before and (d) after heating for 1 hour.

Fig. 9 (a) Images of the water droplet test on heated flexible TFHs with an Ag–Cu alloy electrode. (b) Defrosting test results of the Ag–Cu alloybased THFs before and after frost formation. (c) Photographs demonstrate the heat-shielding performance of the Ag–Cu alloy film. Irradiation of a glass substrate with a halogen lamp increased the temperature of the substrate to 58.4 \degree C.

TFH. Fig. 9a shows pictures of the water droplet test and IR images of the Ag–Cu-based flexible TFHs with a saturation temperature of 104.6 °C. When a DC input voltage of 4 V was supplied to the flexible TFHs, a saturation temperature of 104.6 \degree C was instantly achieved due to a dynamic balance between Joule heating and convection. Therefore, the water droplet disappeared almost immediately due to the high temperature of the Ag-Cu alloy film-based flexible TFHs. Fig. 9b demonstrates the defrost test of the Ag–Cu alloy-based TFHs before and after frost formation. To ensure uniform frost formation on the surface of the Ag–Cu alloy electrode, the sample was placed in a refrigerator for 60 min. At the operating voltage of 4 V, the frost on the surface of the Ag–Cu alloy electrode completely disappeared. Semi-transparent Ag–Cu alloy

electrodes can also be applied to HSFs for BEMS because of their semi-transmittance in the visible wavelength region and high reflection in the NIR region, as shown in Fig. 2c. By effective shielding of heating through a semi-transparent window, total energy consumption in a building can be effectively controlled. Fig. 9c shows a heat shielding test using bare PET film and Ag-Cu alloy-coated PET film. Irradiating glass with light from a halogen lamp resulted in an increase in temperature. The surface temperature of the glass was measured by a IR thermometer (62-MAX, Fluke). Without HSF, the surface of the glass showed a temperature of 58.4 $^{\circ}$ C under halogen lamp irradiation. When the light was blocked by bare PET substrate, there was a small decrease in temperature (57.4 \degree C). However, when the radiation was blocked by semi-transparent Ag–Cu

Fig. 10 Promising applications of Ag–Cu alloy film-based TFHs: (a) transparent toaster, (b) smart window for an automobile, and smart windows for BEMS.

alloy film, the surface temperature of the glass substrate was significantly reduced from 58.4 to 36.9 \degree C, indicating that the semi-transparent Ag–Cu alloy electrodes were effective at shielding the substrate from heat. Therefore, the Ag–Cu alloy coated film can be used as a TFH and HSF simultaneously in automobile windows or smart windows for BEMS.

Fig. 10 demonstrates promising applications of the semitransparent Ag-Cu alloy electrode-based flexible TFHs and HSFs. They can be employed to create semi-transparent toasters (Fig. 10a), defogging/deicing windows (Fig. 10b) for automobiles, and smart windows due to their flexibility and semitransparency. For employment in smart windows for BEMS, large-area Ag-Cu alloy films can be prepared on a PET substrate using a thermal evaporation process. For energy-efficient building, cost-effective defogging/deicing systems and heat shielding systems can be realized by using large smart windows.

4 Conclusions

We developed semi-transparent Ag-Cu alloy films for use as flexible and semi-transparent electrodes for semi-transparent flexible TFHs and HSFs. The effects of Ag-Cu thickness on the electrical, optical, and morphological properties of Ag–Cu electrodes were investigated in detail. Based on figure of merit values calculated from sheet resistance and optical transmittance measurements of Ag–Cu films, we obtained an optimized Ag–Cu alloy film with a sheet resistance of 5.54 Ohm per square, optical transmittance of 53.62%, critical bending radius of 1 mm, and work function of 4.96 eV. Below inner and outer bending radii of 1 mm, the thermally evaporated Ag–Cu alloy film showed no resistance change and no cracks, indicating sufficient flexibility for fabrication of highly flexible TFHs and HSFs. We also investigated the effect of the thickness of the Ag– Cu alloy electrodes on saturation voltage and the temperature of thin film heaters. Furthermore, we evaluated the possibility of using semi-transparent Ag-Cu alloy films as flexible HSFs due to their low optical transmittance in the NIR region. The heat generation and heat shield performance of the optimized Ag– Cu alloy film indicated that it is feasible to use Ag–Cu alloy film

to create energy-efficient automobile windows, smart windows for BEMS, and energy efficient vinyl-houses.

Conflicts of interest

There is no conflicts to declare.

Acknowledgements

This work was supported by the Korea Institute of Energy Technology Evaluation and Planning (KETEP) and the Ministry of Trade, Industry & Energy (MOTIE) of the Republic of Korea (No. 20163010012200). This study also received partial support from the National Research Foundation of Korea (NRF) grant funded by the Korea government (MSIP) (No. 2015R1A2A2A01002415).

References

- 1 S.-H. Park, S.-M. Lee, E.-H. Ko, T.-H. Kim, Y.-C. Nah, S.-J. Lee, J. H. Lee and H.-K. Kim, Sci. Rep., 2016, 6, 33868–33879.
- 2 L. Dai, S. Chen, J. Liu, Y. Gao, J. Zhou, Z. Chen, C. Cao, H. Luo and M. Kanehira, Phys. Chem. Chem. Phys., 2013, 15, 11723–11729.
- 3 R. J. Mortimer, D. R. Rosseinsky and P. M. S. Monk, Electrochromic materials and devices, WILEY-VCH, New Jersey, 2015.
- 4 C. M. Lampert, Sol. Energy Mater. Sol. Cells, 1981, 6, 1–41.
- 5 R. Baetens, B. P. Jelle and A. Gustavsen, Sol. Energy Mater. Sol. Cells, 2010, 94, 87–105.
- 6 D. Michels, J. Hadeler and V. J. H. Lienhard, Exp. Heat Transfer, 1998, 11, 341–359.
- 7 G. Hass and J. E. Waylonis, J. Opt. Soc. Am., 1961, 51, 719– 722.
- 8 E.-H. Ko, H.-J. Kim, S.-J. Lee, J.-H. Lee and H.-K. Kim, RSC Adv., 2016, 6, 46634–46642.
- 9 W. Lan, Y. Chen, Z. Yang, W. Han, J. Zhou, Y. Zhang, J. Wang, G. Tang, Y. Wei, W. Dou, Q. Su and E. Xie, ACS Appl. Mater. Interfaces, 2017, 9, 6644–6651.
- 10 S. Sorel, D. Bellet and J. N. Coleman, ACS Nano, 2014, 8, 4805–4814.
- 11 M. C. Çakır, D. Çalışkan, B. Bütün and E. Özbay, Sensors, 2016, 16, 1612.
- 12 K. Im, K. Cho, K. Kwak, J. Kim and S. Kim, J. Nanosci. Nanotechnol., 2013, 13, 3519–3521.
- 13 D. R. Cairns, R. P. Witte II, D. K. Sparacin, S. M. Sachsman, D. C. Paine and G. P. Crawford, Appl. Phys. Lett., 2000, 76, 1425–1427.
- 14 S.-I. Na, S.-S. Kim, J. Jo and D.-Y. Kim, Adv. Mater., 2008, 20, 4061–4067.
- 15 H.-S. Jang, S. K. Jeon and S. H. Nahm, Carbon, 2011, 49, 111– 116.
- 16 T. J. Kang, T. Kim, S. M. Seo, Y. J. Park and Y. H. Kim, Carbon, 2011, 49, 1087–1093.
- 17 Y.-H. Yoon, J.-W. Song, D. Kim, J. Kim, J.-K. Park, S.-K. Oh and C.-S. Han, Adv. Mater., 2007, 19, 4284–4287.
- 18 J. Kang, H. Kim, K. S. Kim, S.-K. Lee, S. Bae, J.-H. Ahn, Y.-J. Kim, J.-B. Choi and B. H. Hong, Nano Lett., 2011, 11, 5154–5158.
- 19 T. Kim, Y. W. Kim, H. S. Lee, H. Kim, W. S. Yang and K. S. Suh, Adv. Funct. Mater., 2013, 23, 1250–1255.
- 20 K. D. M. Rao and G. U. Kulkarni, Nanoscale, 2014, 6, 5645– 5651.
- 21 J. Kang, Y. Jang, Y. Kim, S.-H. Cho, J. Suhr, B. H. Hong, J.-B. Choi and D. Byun, Nanoscale, 2015, 7, 6567–6573.
- 22 S. Ji, W. He, K. Wang, Y. Ran and C. Ye, Small, 2014, 10, 4951–4960.
- 23 R. Gupta, K. D. M. Rao, K. Srivastava, A. Kumar, S. Kiruthika and G. U. Kulkarni, ACS Appl. Mater. Interfaces, 2014, 6, 13688–13696.
- 24 R. Gupta, K. D. M. Rao, S. Kirthika and G. U. Kulkarni, ACS Appl. Mater. Interfaces, 2016, 8, 12559–12575.
- 25 D. Lordan, M. Burke, M. Manning, A. Martin, A. Amann, D. O'Connell, R. Murphy, C. Lyons and A. J. Quinn, ACS Appl. Mater. Interfaces, 2017, 9, 4932–4940.
- 26 C. Hudaya, B. J. Jeon and J. K. Lee, ACS Appl. Mater. Interfaces, 2015, 7, 57–61.
- 27 K. Kim, J. Kim, B. G. Hyun, S. Ji, S.-Y. Kim, S. Kim, B. W. An and J.-U. Park, Nanoscale, 2015, 7, 14577.
- 28 B. W. An, E.-J. Gwak, K. Kim, Y.-C. Kim, J. Jang, J.-Y. Kim and J.-U. Park, Nano Lett., 2016, 16, 471–478.
- 29 H.-G. Im, B. W. An, J. Jin, J. Jang, Y.-G. Park, J.-U. Park and B.-S. Bae, Nanoscale, 2016, 8, 3916.
- 30 M. J. Bloemer and M. Scalora, Appl. Phys. Lett., 1998, 72, 1676–1678.
- 31 K.-H. Choi, H.-J. Nam, J.-A. Jeong, S.-W. Cho, H.-K. Kim, J.-W. Kang, D.-G. Kim and W.-J. Cho, Appl. Phys. Lett., 2008, 92, 223302.
- 32 H.-S. Roh, S.-H. Cho and W.-J. Lee, Phys. Status Solidi A, 2010, 207, 1558–1562.
- 33 G. Haacke, J. Appl. Phys., 1976, 47, 4086–4089.
- 34 D. S. Ghosh, R. Betancur, T. L. Chen, V. Pruneri and J. Martorell, Sol. Energy Mater. Sol. Cells, 2011, 95, 1228– 1231.
- 35 A. Soon, M. Todorova, B. Delley and C. Stampfl, *Phys. Rev. B*, 2006, 73, 165424.
- 36 D.-Y. Cho, K.-H. Kim, T.-W. Kim, Y.-J. Noh, S.-I. Na, K.-B. Chung and H.-K. Kim, Org. Electron., 2015, 24, 227–233.
- 37 M. Bieletzki, T. Hynninen, T. M. Soini, M. Pivetta, C. R. Henry, A. S. Foster, F. Esch, C. Barth and U. Heiz, Phys. Chem. Chem. Phys., 2010, 12, 3203–3209.
- 38 S. Sadewasser, P. Jelinek, C.-K. Fang, O. Custance, Y. Yamada, Y. Sugimoto, M. Abe and S. Morita, Phys. Rev. Lett., 2009, 103, 266103.
- 39 Y. Zhang, O. Pluchery, L. Caillard, A.-F. Lamic-Humblot, S. Casale, Y. J. Chabal and M. Salmeron, Nano Lett., 2015, 15, 51–55. BSC Advances

19 S. September 2018, B. Dollarda, B. Dollarda, B. Downloaded on 25 September 2017. The Creation September 2017. Dollarda and E. Oday, Streative and J. K. Downloaded J. B. S. Will also knownloaded the same si
	- 40 F. Long, P. Yasaei, R. Sanoj, W. Yao, P. Král, A. Salehi-Khojin and R. Shahbazian-Yassar, ACS Appl. Mater. Interfaces, 2016, 8, 18360–18366.
	- 41 D. Jung, M. Han and G. S. Lee, J. Vac. Sci. Technol. B, 2014, 32, 04E105.